



2FW

Attorney's Docket No. 008209/USA/FEP/GCM/RKK

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Pravin K. Narwankar, et al.

Serial No. 10/772,893

Filed: February 4, 2004

For: Tailoring Nitrogen Profile In Silicon
Oxynitride Using Rapid Thermal
Annealing With Ammonia Under
Ultra-Low Pressure

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

) Examiner: Unassigned

) Art Unit: Unassigned

CHANGE OF CORRESPONDENCE ADDRESS

Sir:

Please change the correspondence address of the above-identified patent application to the following person and address:

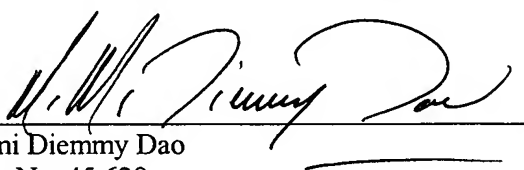
PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O. BOX 450A
Santa Clara, CA. 95052
Phone Number: (408) 727-5555

Please update the Patent Office records to reflect the new correspondence address and telephone number.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

Date: June 14, 2004


Mimi Diemmy Dao
Reg. No. 45,628

12400 Wilshire Boulevard
Seventh Floor
Los Angeles, CA 90025
(408) 720-8300

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313

on June 14, 2004

Date of Deposit

Michelle Begay

Name of Person Mailing Correspondence


Signature

June 14, 2004

BSTZ Docket No. 004887.P776